

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	3402	382/108,141,143-151.ccls.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/13 07:20
L2	3025	356/237.1,237.2.ccls.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/13 07:21
L3	68247	polish\$4 near (pad substrate wafer surface)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/13 07:22
L4	0	1 same (inspect\$3 deteriorat\$4)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/13 07:23
L5	1981	3 same (inspect\$3 deteriorat\$4)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/13 07:23
L6	112	5 same (image camera photodetect\$3)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/13 07:32
L7	8	6 and (surface near condition)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/13 07:25
L8	1	((polish\$4 near pad) and (bi adj level) and deteriorat\$3).clm.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/13 07:26
L9	1	((polish\$4 near pad) and (bi adj level) and deteriorat\$3).clm.	US-PGPUB	OR	ON	2005/10/13 07:26

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L9	1	((polish\$4 near pad) and (bi adj level) and deteriorat\$3).clm.	US-PGPUB	OR	ON	2005/10/13 07:26

INTERFERENCE TEXT SEARCH